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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

K. Kata et al.

Serial No.: 08/533,207

Group Art Unit: 2503

Filed: September 25, 1995

Examiner: Unknown

For: PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE AND
SEMICONDUCTOR WAFER

Commissioner of Patents and Trademarks
Washington, D.C. 20231

NOTICE OF CHANGE OF ADDRESS

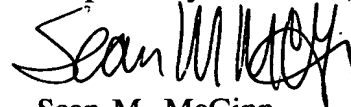
Sir:

Please be advised that the correspondence address of attorneys of record in the
above-identified application have been changed to:

Whitham, Curtis, Whitham & McGinn
Reston International Center
11800 Sunrise Valley Drive, Suite 900
Reston, Virginia 20191

Please change the records in regard to the above-identified application
accordingly. The telephone number for the firm remains (703) 391-2510.

Respectfully submitted,



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